SEP 1 9 2005

DOCKET NO.: **2005717** NO.: NATHS-05717

Customer No. 23990

# PATENT (

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

DARREN LEE RUST, ET AL.

U.S. Serial No.

10/698,007

Filed

October 30, 2003

For

SEMICONDUCTOR WAFER FABRICATION FURNACE IDLE

MONITOR AND METHOD OF OPERATION

Group No.

2125

Examiner

Ryan A. Jarrett

#### MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## CERTIFICATE OF MAILING BY FIRST CLASS MAIL

The undersigned hereby certifies that the following documents:

- 1. Amendment and Response to Office Action;
- 2. Amendment Transmittal Letter (in duplicate);
- 3. Check in the amount of \$200.00 (for additional independent claim); and
- 4. Postcard receipt

Date: SEPTEMBER 15,200

Date: 15, 2005

P.O. Drawer 800889 Dallas, Texas 75380 Phone: (972) 628-3600 Fax: (972) 628-3616

E-mail: wmunck@davismunck.com

Mailer

William A. Munck Reg. No. 39,308



#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Darren Lee Rust, et al.

Serial No.

10/698,007

Filed

October 30, 2003

For

SEMICONDUCTOR WAFER FABRICATION FURNACE

IDLE MONITOR AND METHOD OF OPERATION

Group No.

2125

Examiner

Ryan A. Jarrett

#### MAIL STOP AMENDMENT

Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **AMENDMENT TRANSMITTAL LETTER**

Transmitted herewith is an Amendment and Response to Office Action in the above-identified application. The fee has been calculated as shown below.

CLAIMS AS AMENDED					LARGE ENTITY	
(1)	(2) CLAIMS REMAINING AFTER AMENDMENT	(3)	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR	(5) NUMBER OF EXTRA CLAIMS PRESENT	(6) RATE	(7) ADDITIONAL FEE
TOTAL CLAIMS	22	-	22	-0-	X 50.00 =	\$-0-
IND. CLAIMS	4	-	. 3	1	X 200.00 =	\$200.00
		-	TOTAL ADDITIONAL FEE FOR THIS AMENDMENT			\$200.00

# **DOCKET NO. P05717 (NATI15-05717)**

**SERIAL NUMBER: 10/698,007** 

**PATENT** 



A check in the amount of \$200.00 is attached.

A check in the amount of \$ \_\_\_\_ for a \_\_\_\_-month extension of time is attached.

Please charge any additional fees or credit any overpayment to the Davis Munck Deposit Account No. 50-0208.

A DUPLICATE COPY OF THIS SHEET IS ENCLOSED.

Respectfully submitted,

DAVIS MUNCK, P.C.

Date: Sept 15, 2005

William A. Munck

Registration No. 39,308

P.O. Drawer 800889 Dallas, Texas 75380 Phone: (972) 628-3600

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#### **PATENT**

# **DOCKET NO. P05717 CLIENT NO. NATI15-05717** Customer No. 23990



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Darren Lee Rust, et al.

Serial No.:

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IDLE MONITOR AND METHOD OF OPERATION

Group No.:

2125

Examiner:

Ryan A. Jarrett

#### MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

# **AMENDMENT AND RESPONSE TO OFFICE ACTION**

In response to the Office Action dated June 15, 2005, please amend the above-identified patent application as follows.